

DC Glow Discharge, ID

DC glow discharges in the low pressure regime have long been used for gas lasers and fluorescent lamps. DC discharges are good to study because the solution is time independent. This model shows how to use the Plasma interface to set up an analysis of a positive column. The discharge is sustained by emission of secondary electrons at the cathode.

Model Definition

The DC discharge consists of two electrodes, one powered (the anode) and one grounded (the cathode):

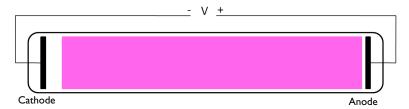


Figure 1: Schematic of the DC discharge. The voltage applied across the electrodes leads to formation of a plasma.

DOMAIN EQUATIONS

The electron density and mean electron energy are computed by solving a pair of driftdiffusion equations for the electron density and mean electron energy. Convection of electrons due to fluid motion is neglected. For detailed information on electron transport see Theory for the Drift Diffusion Interface in the Plasma Module User's Guide.

$$\frac{\partial}{\partial t}(n_e) + \nabla \cdot \left[-n_e(\boldsymbol{\mu}_e \bullet \mathbf{E}) - \mathbf{D}_e \bullet \nabla n_e \right] \, = \, R_e$$

$$\frac{\partial}{\partial t}(n_{\varepsilon}) + \nabla \cdot [-\,n_{\varepsilon}(\boldsymbol{\mu}_{\varepsilon} \bullet \mathbf{E}) - \mathbf{D}_{\varepsilon} \bullet \nabla n_{\varepsilon}] + \mathbf{E} \cdot \boldsymbol{\Gamma}_{e} \, = \, \boldsymbol{R}_{\varepsilon}$$

where:

$$\Gamma_e \, = \, - \, (\mu_e \bullet \mathbf{E}) n_e - \mathbf{D}_e \bullet \nabla n_e$$

The electron source R_e and the energy loss due to inelastic collisions R_{ϵ} are defined later. The electron diffusivity, energy mobility and energy diffusivity are computed from the electron mobility using:

$$\mathbf{D}_{e} = \mu_{e} T_{e}, \, \mu_{\varepsilon} = \left(\frac{5}{3}\right) \mu_{e}, \, \mathbf{D}_{\varepsilon} = \mu_{\varepsilon} T_{e}$$

The source coefficients in the above equations are determined by the plasma chemistry using rate coefficients. Suppose that there are M reactions which contribute to the growth or decay of electron density and P inelastic electron-neutral collisions. In general $P \gg M$. In the case of rate coefficients, the electron source term is given by:

$$R_e = \sum_{j=1}^{M} x_j k_j N_n n_e$$

where x_j is the mole fraction of the target species for reaction j, k_j is the rate coefficient for reaction j (m³/s), and N_n is the total neutral number density (1/m³). For DC discharges it is better practice to use Townsend coefficients instead of rate coefficients to define reaction rates. Townsend coefficients provide a better description of what happens in the cathode fall region Ref 1. When Townsend coefficients are used, the electron source term is given by:

$$R_e = \sum_{j=1}^{M} x_j \alpha_j N_n |\Gamma_e|$$

where α_j is the Townsend coefficient for reaction j (m²) and Γ_e is the electron flux as defined above $(1/(m^2 \cdot s))$. Townsend coefficients can increase the stability of the numerical scheme when the electron flux is field driven as is the case with DC discharges. The electron energy loss is obtained by summing the collisional energy loss over all reactions:

$$R_{\varepsilon} = \sum_{j=1}^{P} x_{j} k_{j} N_{n} n_{e} \Delta \varepsilon_{j}$$

where $\Delta \varepsilon_j$ is the energy loss from reaction j (V). The rate coefficients may be computed from cross section data by the following integral:

$$k_k = \gamma \int_0^\infty \varepsilon \sigma_k(\varepsilon) f(\varepsilon) d\varepsilon$$

where $\gamma = (2q/m_e)^{1/2}$ (C^{1/2}/kg^{1/2}), m_e is the electron mass (kg), ε is energy (V), σ_k is the collision cross section (m²) and f is the electron energy distribution function. In this

case a Maxwellian EEDF is assumed. When Townsend coefficients are used, the electron energy loss is taken as:

$$R_{\varepsilon} = \sum_{j=1}^{P} x_{j} \alpha_{j} N_{n} |\Gamma_{e}| \Delta \varepsilon_{j}$$

For nonelectron species, the following equation is solved for the mass fraction of each species. For detailed information on the transport of the nonelectron species see *Theory for the Heavy Species Transport Interface* in the *Plasma Module User's Guide*.

$$\rho \frac{\partial}{\partial t}(w_k) + \rho(\mathbf{u} \cdot \nabla)w_k = \nabla \cdot \mathbf{j}_k + R_k$$

The electrostatic field is computed using the following equation:

$$-\nabla \cdot \varepsilon_0 \varepsilon_r \nabla V = \rho$$

The space charge density ρ is automatically computed based on the plasma chemistry specified in the model using the formula:

$$\rho = q \left(\sum_{k=1}^{N} Z_k n_k - n_e \right)$$

For detailed information about electrostatics see *Theory for the Electrostatics Interface* in the *Plasma Module User's Guide*.

BOUNDARY CONDITIONS

Unlike RF discharges, the mechanism for sustaining the discharge is emission of secondary electrons from the cathode. An electron is emitted from the cathode surface with a specified probability when struck by an ion. These electrons are then accelerated by the strong electric field close to the cathode where they acquire enough energy to initiate ionization. The net result is a rapid increase in the electron density close to the cathode in a region often known as the *cathode fall* or *Crookes dark space*.

Electrons are lost to the wall due to random motion within a few mean free paths of the wall and gained due to secondary emission effects, resulting in the following boundary condition for the electron flux:

$$\mathbf{n} \cdot \Gamma_e = \left(\frac{1}{2} \mathbf{v}_{e, \text{ th}} n_e\right) - \sum_p \gamma_p (\Gamma_p \cdot \mathbf{n}) \tag{1}$$

and the electron energy flux:

$$\mathbf{n} \cdot \Gamma_{\varepsilon} = \left(\frac{5}{6} \mathbf{v}_{e, \, \text{th}} n_{\varepsilon}\right) - \sum_{p} \varepsilon_{p} \gamma_{p} (\Gamma_{p} \cdot \mathbf{n}) \tag{2}$$

The second term on the right-hand side of Equation 1 is the gain of electrons due to secondary emission effects, γ_p being the secondary emission coefficient. The second term in Equation 2 is the secondary emission energy flux, ε_p being the mean energy of the secondary electrons. For the heavy species, ions are lost to the wall due to surface reactions and the fact that the electric field is directed toward the wall:

$$\mathbf{n} \cdot \mathbf{j}_k = M_w R_k + M_w c_k Z \mu_k (\mathbf{E} \cdot \mathbf{n}) [Z_k \mu_k (\mathbf{E} \cdot \mathbf{n}) > 0]$$

PLASMA CHEMISTRY

Argon is one of the simplest mechanisms to implement at low pressures. The electronically excited states can be lumped into a single species which results in a chemical mechanism consisting of only 3 species and 7 reactions (electrons impact cross sections are obtained from Ref. 2):

TABLE I: TABLE OF COLLISIONS AND REACTIONS MODELED.

REACTION	FORMULA	TYPE	$\Delta\epsilon(eV)$
1	e+Ar=>e+Ar	Elastic	0
2	e+Ar=>e+Ars	Excitation	11.5
3	e+Ars=>e+Ar	Superelastic	-11.5
4	e+Ar=>2e+Ar+	Ionization	15.8
5	e+Ars=>2e+Ar+	Ionization	4.24
6	Ars+Ars=>e+Ar+Ar+	Penning ionization	-
7	Ars+Ar=>Ar+Ar	Metastable quenching	-

In this discharge, the electron density and the density of the excited species are relatively low, so stepwise ionization is not as important as in high density discharges. In addition to volumetric reactions, the following surface reactions are implemented:

TABLE 2: TABLE OF SURFACE REACTIONS.

REACTION	FORMULA	STICKING COEFFICIENT
1	Ars=>Ar	1
2	Ar+=>Ar	I

When a metastable argon atom makes contact with the wall, it reverts to the ground state argon atom with some probability (the sticking coefficient).

The electric potential, electron density, and mean electron energy are all quantities of interest. Most of the variation in each of these quantities occurs along the axial length of the column. Figure 2 plots the electron density in the column. The electron density peaks in the region between the cathode fall and positive column. This region is sometimes referred to as Faraday dark space. The electron density obtained in this 1D model is different than that obtained in the 2D model because the diffusive loss of electrons to the outer walls and the accumulation of surface charge on the walls are not modeled.

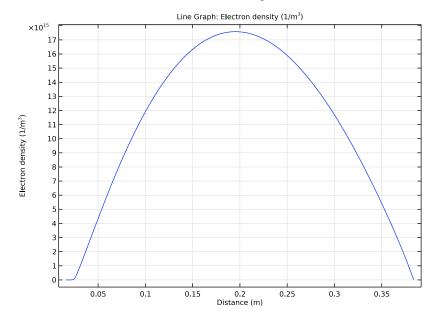


Figure 2: Electron density along the axial length of the positive column.

In Figure 3 the electric potential is plotted along the axial length of the column. Notice that the potential profile is significantly different from the linear drop in potential which results in the absence of the plasma. The strong electric field in the cathode region can lead to high energy ion bombardment of the cathode. Heating of the cathode surface occurs which may in turn lead to thermal electron emission where additional electrons are emitted from the cathode surface.

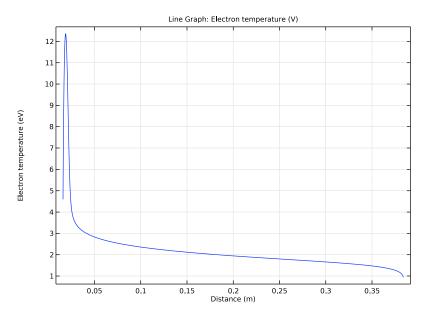


Figure 3: Electron temperature along the axial length of the positive column.

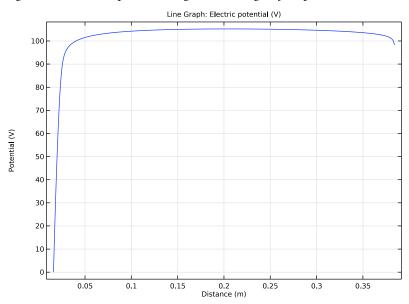


Figure 4: Potential along the axial length of the positive column.

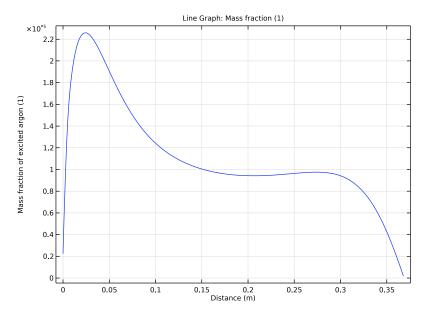


Figure 5: Mass fraction of excited argon atoms along the axial length of the positive column.

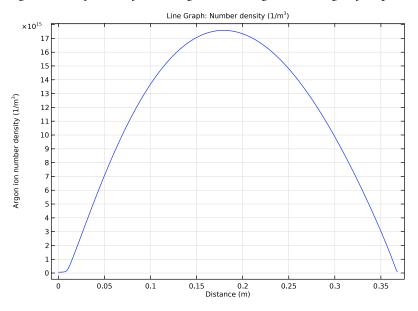


Figure 6: Number density of argon ions along the axial length of the positive column.

The plasma current due to electrons, ions and their sum is plotted in Figure 7. As expected, the ion current is highest at the cathode and increases sharply in the cathode fall region. The ion bombardment of the cathode results in an electron current released from the electrode. The electron current increases sharply in the cathode fall region because the high electron temperature results in production of new electrons which then contribute to the total electron current. Once the electrons pass the cathode fall region, the electron current density further increases due to production of new electrons through electron impact ionization with the background gas.

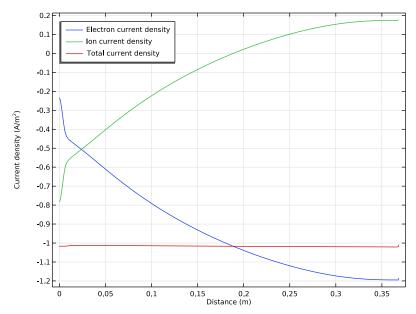


Figure 7: Electron current density (blue), ion current density (green), and total current density (red) along the axial length of the positive column.

References

- 1. M.A. Lieberman and A.J. Lichtenberg, Principles of Plasma Discharges and Materials Processing, John Wiley & Sons, 2005.
- 2. Phelps database, www.lxcat.net, retrieved 2017.

Application Library path: Plasma_Module/Direct_Current_Discharges/ positive_column_1d

Modeling Instructions

From the File menu, choose New.

NEW

In the New window, click Model Wizard.

MODEL WIZARD

- I In the Model Wizard window, click ID.
- 2 In the Select Physics tree, select Plasma > Plasma (plas).
- 3 Click Add.
- 4 Click 🔵 Study.
- 5 In the Select Study tree, select General Studies > Time Dependent.
- 6 Click M Done.

GEOMETRY I

The geometry interval is defined to be consistent with the 2D version of the model, which is available in the Application Library.

Interval I (iI)

- I In the Model Builder window, under Component I (compl) right-click Geometry I and choose Interval.
- 2 In the Settings window for Interval, locate the Interval section.
- **3** In the table, enter the following settings:

Coordinates (m)	
0.016	
0.384	

DEFINITIONS

Variables 1

I In the **Definitions** toolbar, click **a= Local Variables**.

- 2 In the Settings window for Variables, locate the Variables section.
- **3** In the table, enter the following settings:

Name	Expression	Unit	Description
mueN	1E24[1/(m*V*s)]	I/(V·m·s)	Electron mobility
V0	200[V]	V	Applied voltage
Wf	5		Surface work function
р0	0.1[torr]	Pa	Gas pressure

PLASMA (PLAS)

Cross Section Import 1

- I In the Physics toolbar, click A Global and choose Cross Section Import.
- 2 In the Settings window for Cross Section Import, locate the Cross Section Import section.
- 3 Click Browse.
- **4** Browse to the model's Application Libraries folder and double-click the file Ar xsecs.txt.
- 5 Click | Import.
- 6 In the Model Builder window, click Plasma (plas).
- 7 In the Settings window for Plasma, locate the Plasma Properties section.
- 8 Select the Use reduced electron transport properties checkbox.
 - Because you will examine the electron, ion, and net currents flowing in the plasma, raise the element order to 2. The current density is computed from space derivatives of the charge carrying degrees of freedom, so using 2nd order shape functions gives a more accurate value for the current density.
- 9 Click to expand the Discretization section. From the Formulation list, choose Finite element, log formulation (quadratic shape function).

Plasma Model I

- I In the Model Builder window, click Plasma Model I.
- 2 In the Settings window for Plasma Model, locate the Model Inputs section.
- **3** In the p_A text field, type p0.
- 4 Locate the Electron Density and Energy section. In the $\mu_e N_n$ text field, type mueN.
 - Now change the way the source coefficients for electronic excitation and ionization are specified. By default, COMSOL Multiphysics computes rate coefficients based on the cross section data you supplied. For DC discharges, Townsend coefficients provide a

more accurate description of the cathode fall region so they should be used. The Townsend coefficients are typically computed using the **Boltzmann Equation, Two-Term Approximation** interface.

2: e+Ar=>e+Ars

- I In the Model Builder window, click 2: e+Ar=>e+Ars.
- 2 In the Settings window for Electron Impact Reaction, locate the Collision section.
- 3 From the Specify reaction using list, choose Use lookup table.
- 4 Locate the Reaction Parameters section. From the Rate constant form list, choose Townsend coefficient.
- 5 Find the Townsend coefficient data subsection. Click **Load from File**.
- 6 Browse to the model's Application Libraries folder and double-click the file town2.txt.

4: e+Ar=>2e+Ar+

- I In the Model Builder window, click 4: e+Ar=>2e+Ar+.
- 2 In the Settings window for Electron Impact Reaction, locate the Collision section.
- 3 From the Specify reaction using list, choose Use lookup table.
- 4 Locate the Reaction Parameters section. From the Rate constant form list, choose Townsend coefficient.
- 5 Find the Townsend coefficient data subsection. Click **Load from File**.
- 6 Browse to the model's Application Libraries folder and double-click the file town4.txt.

Reaction 1

- I In the Physics toolbar, click Domains and choose Reaction.
- 2 In the Settings window for Reaction, locate the Reaction Formula section.
- 3 In the Formula text field, type Ars+Ars=>e+Ar+Ar+.
- **4** Locate the **Reaction Parameters** section. In the $k^{\rm f}$ text field, type 3.734E8.

Reaction 2

- I In the **Physics** toolbar, click **Domains** and choose **Reaction**.
- 2 In the Settings window for Reaction, locate the Reaction Formula section.
- 3 In the Formula text field, type Ars+Ar=>Ar+Ar.
- **4** Locate the **Reaction Parameters** section. In the $k^{\rm f}$ text field, type 1807.

Species: Ar

- I In the Model Builder window, click Species: Ar.
- 2 In the Settings window for Species, locate the Species Formula section.

- 3 Select the From mass constraint checkbox.
- 4 Locate the General Parameters section. From the Preset species data list, choose Ar.

When solving a reacting flow problem there always needs to be one species which is selected to fulfill the mass constraint. This should be taken as the species with the largest mass fraction.

Species: Ars

- I In the Model Builder window, click Species: Ars.
- 2 In the Settings window for Species, locate the General Parameters section.
- 3 From the Preset species data list, choose Ar.

When solving a plasma problem the plasma must be initially charge neutral. COMSOL automatically computes the initial concentration of a selected ionic species such that the electroneutrality constraint is satisfied.

Species: Ar+

- I In the Model Builder window, click Species: Ar+.
- 2 In the Settings window for Species, locate the Species Formula section.
- 3 Select the Initial value from electroneutrality constraint checkbox.
- 4 Locate the General Parameters section. From the Preset species data list, choose Ar.

Now add a surface reaction which describes the neutralization of argon ions on the electrode. Secondary emission of electrons is required to sustain the discharge, so enter the emission coefficient and an estimate of the mean energy of the secondary electrons based on the ionization energy threshold and the work function of the surface.

Surface Reaction 1

- I In the Physics toolbar, click Boundaries and choose Surface Reaction.
- 2 In the Settings window for Surface Reaction, locate the Reaction Formula section.
- 3 In the Formula text field, type Ar+=>Ar.
- 4 Select Boundary 1 only.

Make the secondary emission coefficient 0.35 and set the mean energy of the secondary electrons to be the ionization energy (given by the expression plas.de_4) minus twice the work function of the electrode.

- **5** Locate the **Secondary Emission Parameters** section. In the γ_i text field, type 0.35.
- **6** In the ε_i text field, type plas.de_4-2*Wf.

Surface Reaction 2

I In the Physics toolbar, click — Boundaries and choose Surface Reaction.

- 2 In the Settings window for Surface Reaction, locate the Reaction Formula section.
- 3 In the Formula text field, type Ar+=>Ar.
- 4 Select Boundary 2 only.

Surface Reaction 3

- I In the Physics toolbar, click Boundaries and choose Surface Reaction.
- 2 In the Settings window for Surface Reaction, locate the Reaction Formula section.
- 3 In the Formula text field, type Ars=>Ar.
- 4 Click in the **Graphics** window and then press Ctrl+A to select both boundaries.

Wall I

- I In the Physics toolbar, click Boundaries and choose Wall.
- 2 Click in the **Graphics** window and then press Ctrl+A to select both boundaries.

Ground 1

- I In the Physics toolbar, click Boundaries and choose Ground.
- 2 Select Boundary 1 only.

Metal Contact 1

- I In the Physics toolbar, click Boundaries and choose Metal Contact.
- 2 Select Boundary 2 only.
- 3 In the Settings window for Metal Contact, locate the Terminal section.
- **4** In the V_0 text field, type V0.
- 5 Locate the Circuit Settings section. From the Circuit type list, choose Ballast resistor.
- **6** In the Rb text field, type 10000[ohm].

MESH I

Edge I

In the Mesh toolbar, click A Edge.

Distribution I

- I Right-click **Edge I** and choose **Distribution**.
- 2 In the Settings window for Distribution, locate the Distribution section.
- 3 From the Distribution type list, choose Predefined.
- 4 In the Number of elements text field, type 200.
- 5 In the Element ratio text field, type 50.

- 6 From the Growth rate list, choose Exponential.
- 7 Select the Symmetric distribution checkbox.
- 8 Click III Build All.

STUDY I

Step 1: Time Dependent

- I In the Model Builder window, under Study I click Step I: Time Dependent.
- 2 In the Settings window for Time Dependent, locate the Study Settings section.
- 3 In the Output times text field, type 0.
- 4 Click Range.
- 5 In the Range dialog, choose Number of values from the Entry method list.
- 6 In the Start text field, type -8.
- 7 In the Stop text field, type 0.
- 8 In the Number of values text field, type 101.
- 9 From the Function to apply to all values list, choose explo(x) Exponential function (base 10).
- 10 Click Add.
- II In the Study toolbar, click **Compute**.

RESULTS

Electron Density (plas)

- I In the Settings window for ID Plot Group, locate the Data section.
- 2 From the Time selection list, choose Last.
- **3** Locate the **Plot Settings** section.
- 4 Select the **x-axis label** checkbox. In the associated text field, type **Distance** (m).
- 5 Select the y-axis label checkbox.
- **6** Click the **Zoom Extents** button in the **Graphics** toolbar.

Electron Temperature (plas)

- I In the Model Builder window, click Electron Temperature (plas).
- 2 In the Settings window for ID Plot Group, locate the Data section.
- 3 From the Time selection list, choose Last.
- 4 Locate the **Plot Settings** section.

- 5 Select the x-axis label checkbox. In the associated text field, type Distance (m).
- 6 Select the y-axis label checkbox. In the associated text field, type Electron temperature (eV).
- 7 Click the **Zoom Extents** button in the **Graphics** toolbar.

Electric Potential (plas)

- I In the Model Builder window, click Electric Potential (plas).
- 2 In the Settings window for ID Plot Group, locate the Data section.
- **3** From the **Time selection** list, choose **Last**.
- 4 Locate the Plot Settings section.
- 5 Select the x-axis label checkbox. In the associated text field, type Distance (m).
- **6** Select the **y-axis label** checkbox. In the associated text field, type Potential (V).
- 7 Click the **Zoom Extents** button in the **Graphics** toolbar.

Excited Argon Mass Fraction

- I In the Results toolbar, click \to ID Plot Group.
- 2 In the Settings window for ID Plot Group, type Excited Argon Mass Fraction in the Label text field.
- 3 Locate the Data section. From the Time selection list, choose Last.
- 4 Locate the Plot Settings section.
- 5 Select the x-axis label checkbox. In the associated text field, type Distance (m).
- 6 Select the y-axis label checkbox. In the associated text field, type Mass fraction of excited argon (1).

Line Graph 1

- I Right-click Excited Argon Mass Fraction and choose Line Graph.
- 2 Select Domain 1 only.
- 3 In the Settings window for Line Graph, click Replace Expression in the upper-right corner of the y-Axis Data section. From the menu, choose Component I (compl) > Plasma > Mass fractions > plas.wArs - Mass fraction - I.
- 4 In the Excited Argon Mass Fraction toolbar, click **Plot**.

Argon Ion Number Density

- I In the Results toolbar, click \sim ID Plot Group.
- 2 In the Settings window for ID Plot Group, type Argon Ion Number Density in the Label text field.

- 3 Locate the Data section. From the Time selection list, choose Last.
- 4 Locate the Plot Settings section.
- 5 Select the x-axis label checkbox. In the associated text field, type Distance (m).
- **6** Select the **y-axis label** checkbox. In the associated text field, type Argon ion number density (1/m³).

Line Graph 1

- I Right-click Argon Ion Number Density and choose Line Graph.
- 2 Select Domain 1 only.
- 3 In the Settings window for Line Graph, click Replace Expression in the upper-right corner of the y-Axis Data section. From the menu, choose Component I (compl) > Plasma > Number densities > plas.n_wAr_Ip Number density I/m³.
- 4 In the Argon Ion Number Density toolbar, click **Plot**.

Current Density

- I In the Model Builder window, right-click Argon Ion Number Density and choose Duplicate.
- 2 In the Settings window for ID Plot Group, type Current Density in the Label text field.
- 3 Click to expand the **Title** section. From the **Title type** list, choose **None**.
- **4** Locate the **Plot Settings** section. In the **y-axis label** text field, type Current density (A/m²).
- 5 Locate the Legend section. From the Position list, choose Upper left.

Line Graph 1

- I In the Model Builder window, expand the Current Density node, then click Line Graph I.
- 2 In the Settings window for Line Graph, click Replace Expression in the upper-right corner of the y-Axis Data section. From the menu, choose Component I (compl) > Plasma > Current > Electron current density A/m² > plas.Jelx Electron current density, x-component.
- 3 Click to expand the Quality section. From the Resolution list, choose No refinement.
- 4 From the Recover list, choose Within domains.
- 5 Click to expand the **Legends** section. Select the **Show legends** checkbox.
- 6 From the Legends list, choose Manual.
- 7 In the Current Density toolbar, click **Plot**.

8 In the table, enter the following settings:

Legends	_egends		
Electron	current	density	

Line Graph 2

- I Right-click Results > Current Density > Line Graph I and choose Duplicate.
- 2 In the Settings window for Line Graph, click Replace Expression in the upper-right corner of the y-Axis Data section. From the menu, choose Component I (compl) > Plasma > Species > Species wAr_Ip > Ion current density - A/m² > plas.Jix_wAr_Ip -Ion current density, x-component.
- 3 In the Current Density toolbar, click **Plot**.
- **4** Locate the **Legends** section. In the table, enter the following settings:

Legends		
Ion	current	density

Line Graph 3

- I Right-click Line Graph I and choose Duplicate.
- 2 In the Settings window for Line Graph, locate the y-Axis Data section.
- 3 In the Expression text field, type plas.Jix_wAr_1p+plas.Jelx.
- **4** Locate the **Legends** section. In the table, enter the following settings:

Legends Total current density

5 In the Current Density toolbar, click **Plot**.